

PATENT

Docket No.:JCLA8556-D

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Applicant : JING-HORNG GAU et al.
Filed : Herewith
For : VARIABLE CAPACTOR STRUCTURE AND METHOD OF
MANUFACTURE

PRELIMINARY AMENDMENT

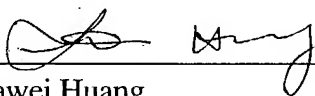
Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Prior to the examination on merits, please amend the above-identified application as shown in the attached sheets. No new matter has added through the amendment. Entry of the amendment is requested.

Respectfully submitted,

Dated: 7/29/2003

By: 
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